



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5 Applicant: Chih-Ning Wu
Examiner: Umez Eronini, Lynette T
Filing Date: 07/16/2001 Art Unit:1765
App. No.: 09/682,054 Docket No.: NAUP0374USA

Do Not Enter
Amendment

10 Title: EXTRUSION-FREE WET CLEANING PROCESS FOR COPPER-DUAL
DAMASCENE STRUCTURES

12/17/03

To: Commissioner for Patents

P.O. Box 1450

15 Alexandria, VA 22313-1450

Subject: Response to the Office action dated 09/23/2003

20 Dear Sir or Madame:

INTRODUCTORY COMMENTS

25 In response to the Office action identified above, the
above-identified application is to be amended as indicated in
the following sections. Consideration of all amendments is
politely requested.